PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Hirotoshi Ichikawa	04/13/2009
Yoshihiro Maeda	04/13/2009
Fusao Ishii	04/13/2009

RECEIVING PARTY DATA

Name:	Silicon Quest Kabushiki-Kaisha	
Street Address:	1588-128 Koshigoe Kamakura-Shi	
City:	Kanagawa-Ken, 248-0033	
State/Country:	JAPAN	

Name:	Olympus Corporation	
Street Address:	Shinjukumonolith, 3-1 Nishi-Shinjuku 2-chome	
City:	Shinjuku-ku, Tokyo 163-0914	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12590754

CORRESPONDENCE DATA

Fax Number: (650)949-4118

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Email: BolnLin@aol.com

Correspondent Name: Bo-In Lin

Address Line 1: 13445 Mandoli Drive

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ATTORNEY DOCKET NUMBER: SQ-0751

NAME OF SUBMITTER: Bo-In Lin

PATENT

501027646 REEL: 023581 FRAME: 0878

12590754

:H \$40,00

Total Attachments: 3

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> PATENT REEL: 023581 FRAME: 0879

Docket No. SQ-0751

INVENTOR AND CITY

Whereas, i Hirotoshi Ichikawa of

Hachioji, Tokyo, Japan

have invented:

TITLE

Structural Body Electrically Connected Via

Semiconductor Material Layer

and executed a United States patent application therefor

DATE

on

INVENTOR SIGNED THE DECLARATION

04/13/2009

Whereas, Olympus Corporation having a place of business at Tokyo, Japan, (hereinafter called Olympus), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to Olympus, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to Olympus its successors and assigns; and I hereby agree that Olympus may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

Hirotoshi Idrikama

CITY AND

Signed and Sealed at Tokyo, Japan

on

04/13/2009

SIGNATURE OF INVENTOR

PATENT REEL: 023581 FRAME: 0880

Docket No. SQ0751

INVENTOR AND CITY

Whereas, I Yoshihiro Maeda of

Hachioji, Tokyo, Japan

have invented:

TITLE

Structural Body Electrically Connected Via

Semiconductor Material Layer

and executed a United States patent application therefor

DATE
INVENTOR
SIGNED THE
DECLARATION

April 13, 2009

Whereas, Olympus Corporation having a place of business at Tokyo, Japan, (hereinafter called Olympus), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to Olympus, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to Olympus its successors and assigns; and I hereby agree that Olympus may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

Joshilio Mada

CITY AND DATE

Signed and Sealed at Tokyo, Japan

on 4/13/09

SIGNATURE OF INVENTOR

ASSIGNMENT

INVENTOR

Whereas, I, Fusao Ishii of 4405 Bayard Street

AND CITY

Pittsburgh, Pennsylvania, 15213

have invented:

TITLE:

Structural Body Electrically Connected Via Semiconductor Material Layer

DATE INVENTOR and executed a United States patent application therefor

SIGNED THE DECLARATION

on 4/13/09;

Whereas, Silicon Quest Kabushiki-Kaisha, having a place of business at Kamakura, Japan, (hereinafter called Silicon Quest), desires to acquire the entire right, title and interest of said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to Silicon Quest, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to Silicon Quest its successors and assigns; and I hereby agree that Silicon Quest may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by

CITY AND

Signed and Sealed Pennsylvania, USA

DATE

on 4/13/09

SIGNATURE OF INVENTOR

PATENT

REEL: 023581 FRAME: 0882

RECORDED: 11/30/2009